

10584950 - GAU: 2851

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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128620		APPLICATION NO. New U.S. Patent Application																	
INFORMATION DISCLOSURE STATEMENT																							
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<table border="1"> <tr> <td colspan="8">APPLICANT Hiroyuki NAGASAKA</td> </tr> <tr> <td colspan="6">FILING DATE July 5, 2006</td> <td colspan="2"></td> </tr> </table>								APPLICANT Hiroyuki NAGASAKA								FILING DATE July 5, 2006							
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Date: July 5, 2006

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /P.K./

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